

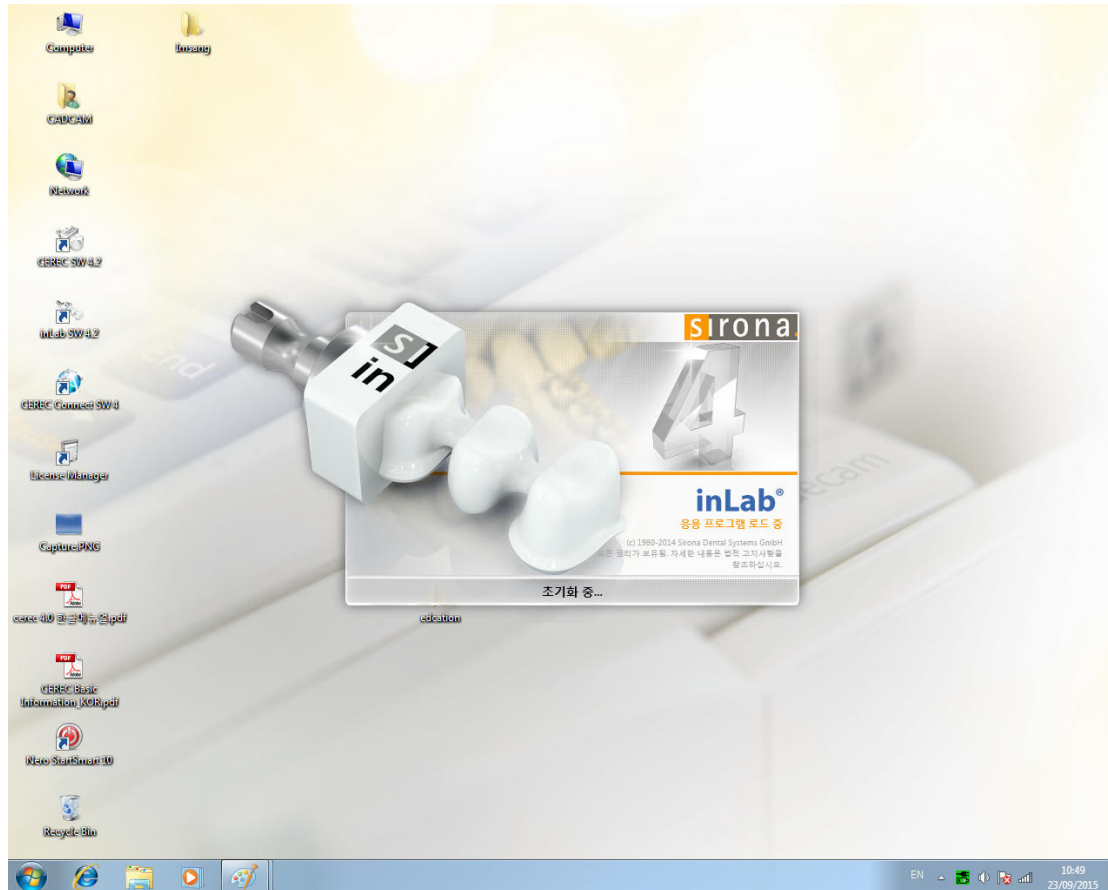


New Product Introduction Link Abutment

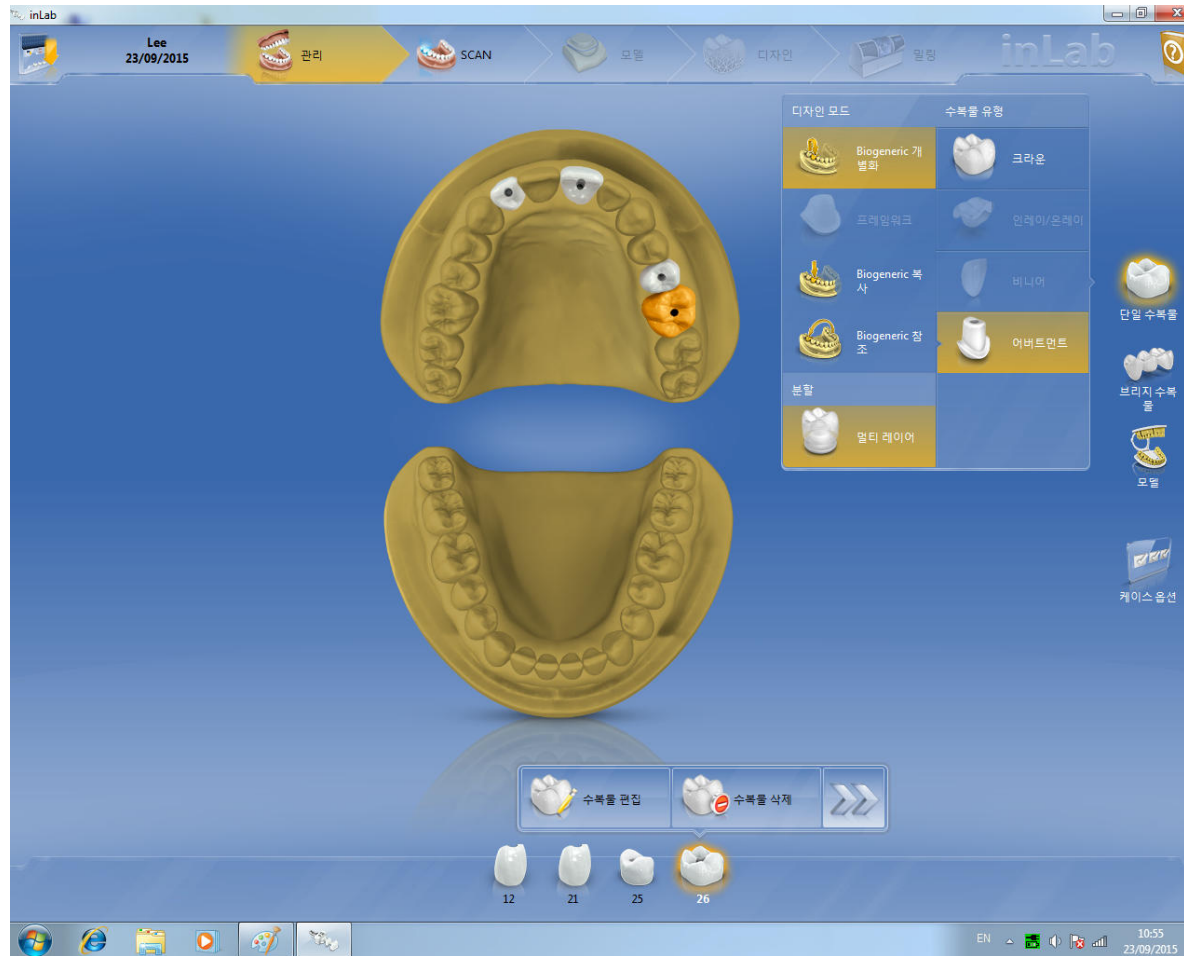
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Link Abutment for CEREC

Software

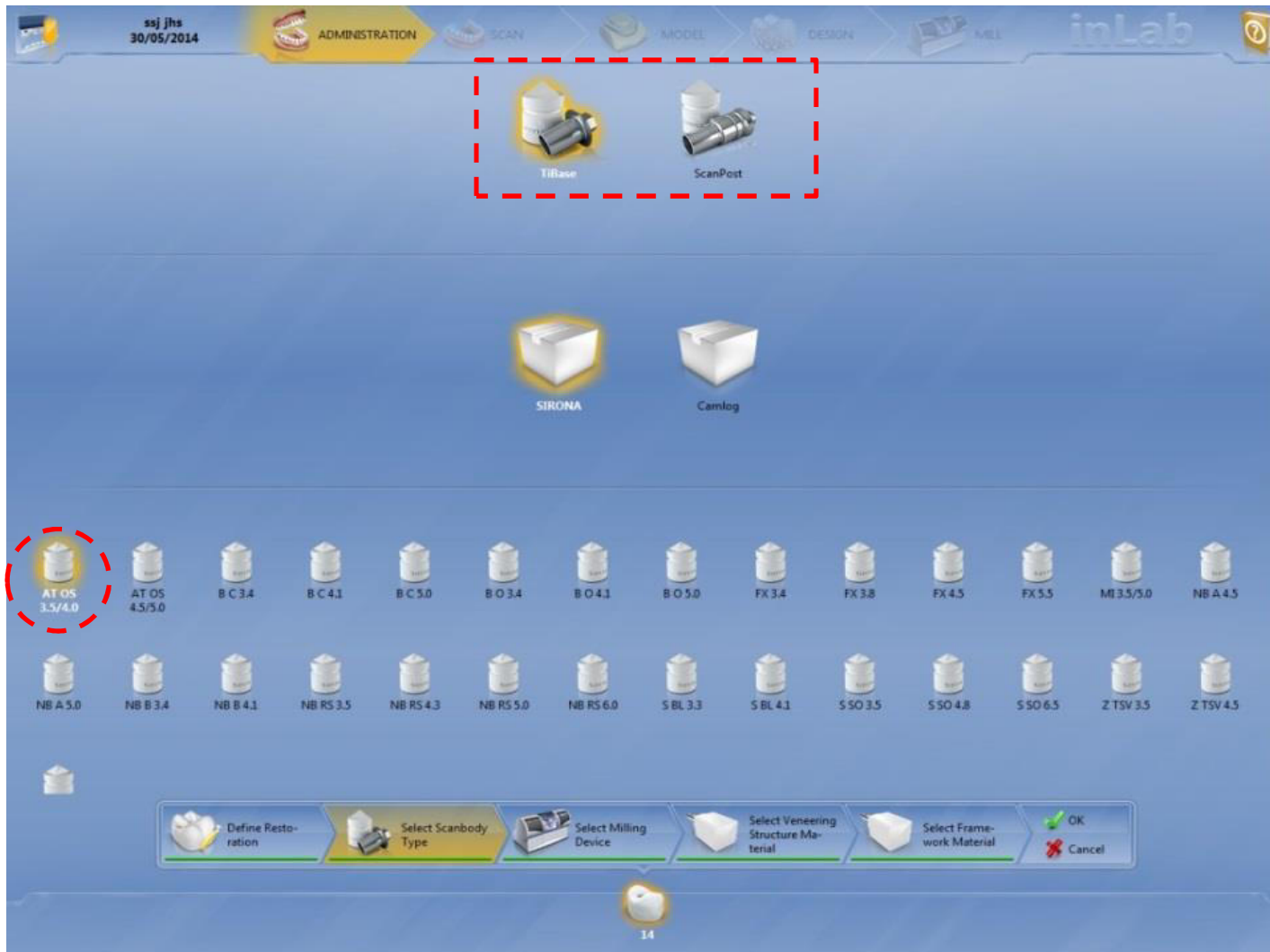


Link Abutment for CEREC



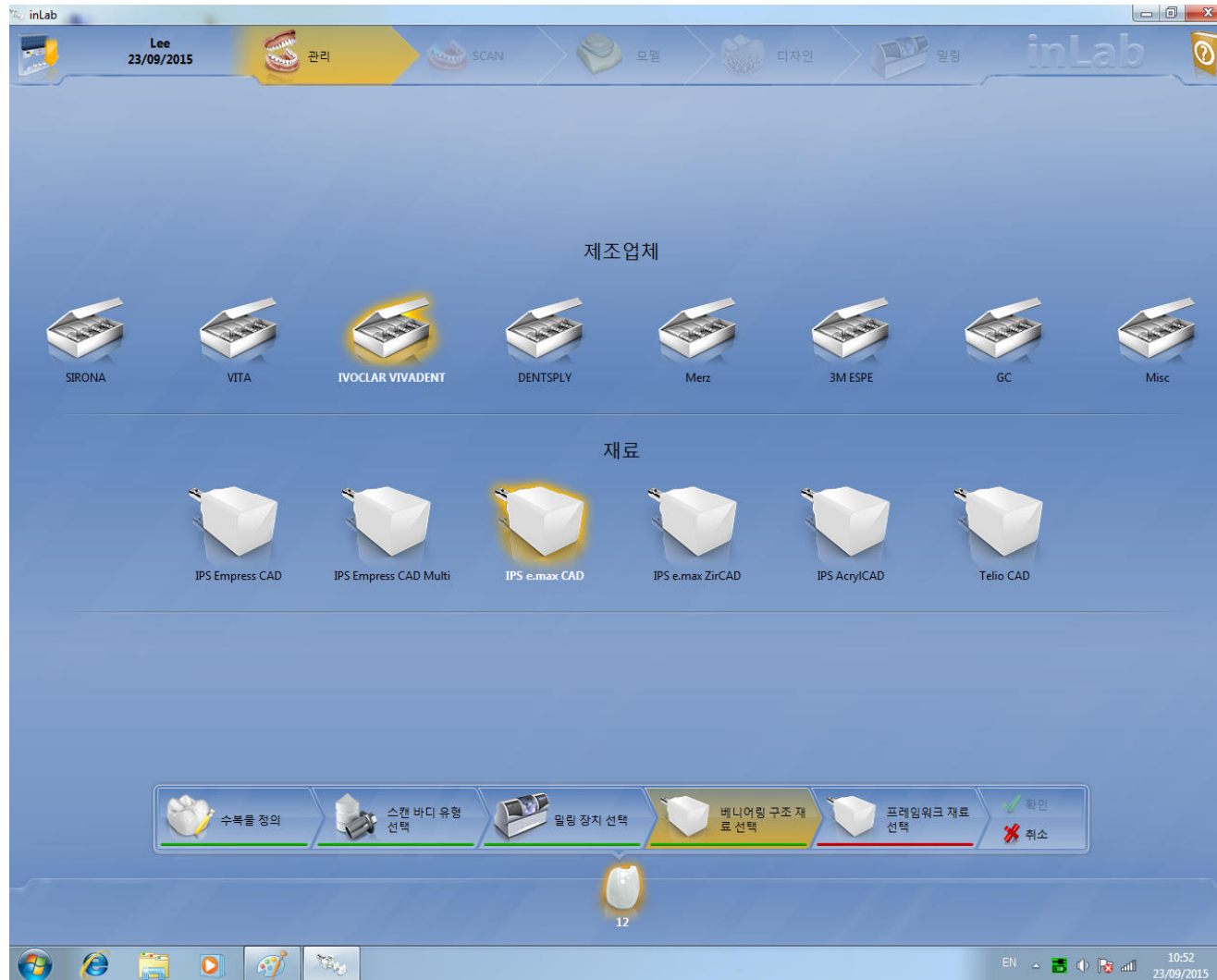
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•AT OS 3.5/4.0

Link Abutment for CEREC



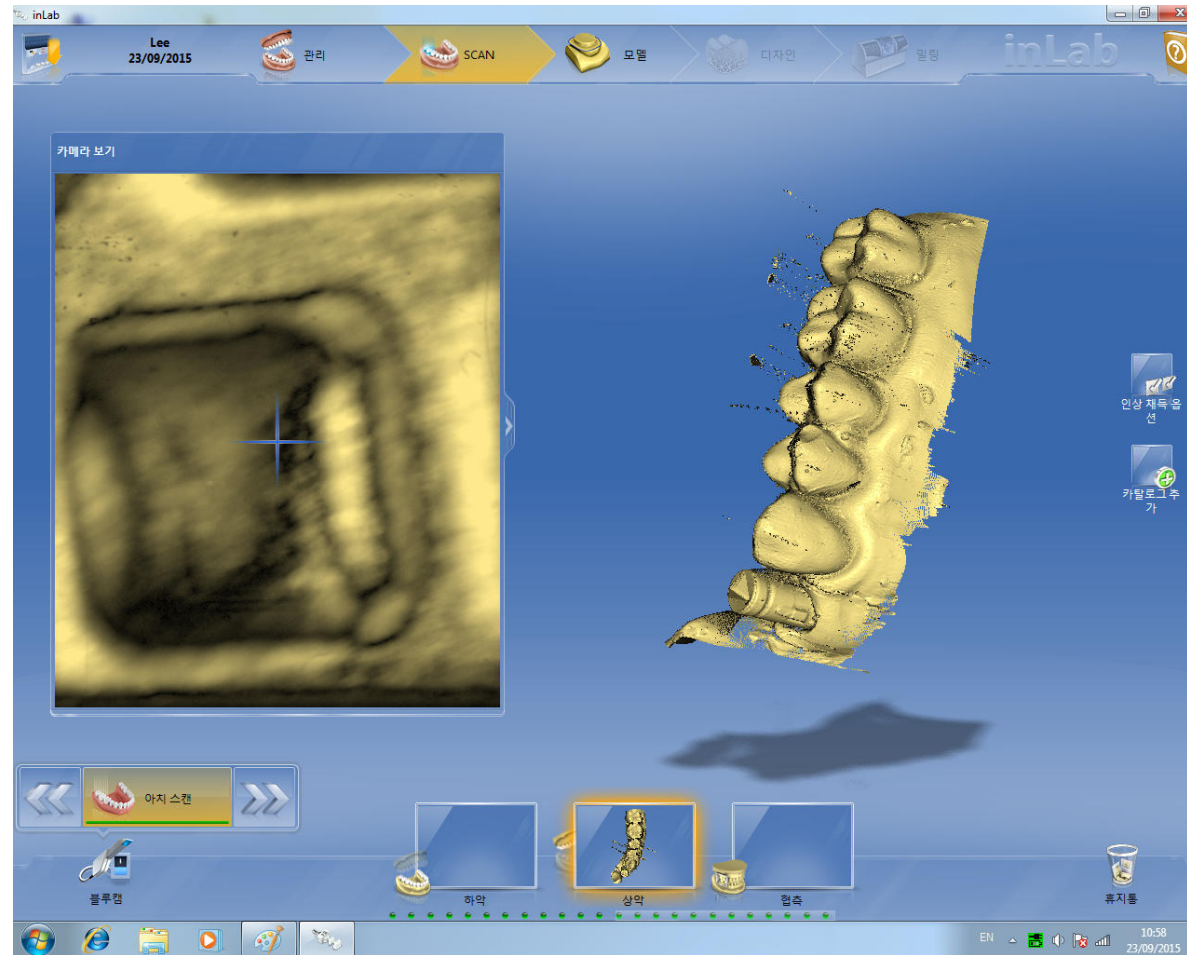
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Cerec용 Link Abutment



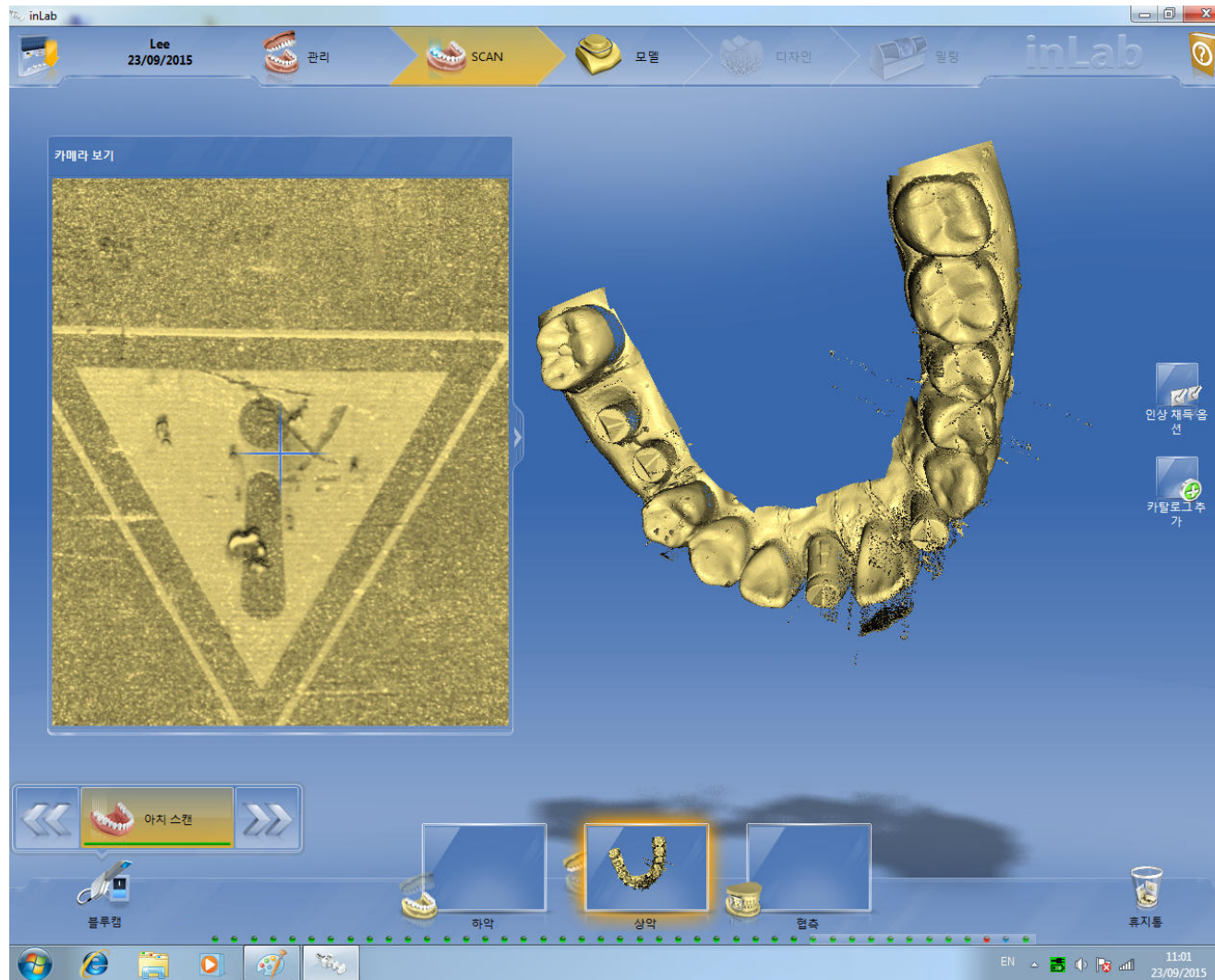
- S/W에서 Link ABT를 제작할 재료를 선택합니다. '**Sirona -> Meso**'를 선택합니다.
여기까지 설정한 후 확인을 누르면 다음 단계로 스캔 과정으로 넘어가게 됩니다.

Link Abutment for CEREC



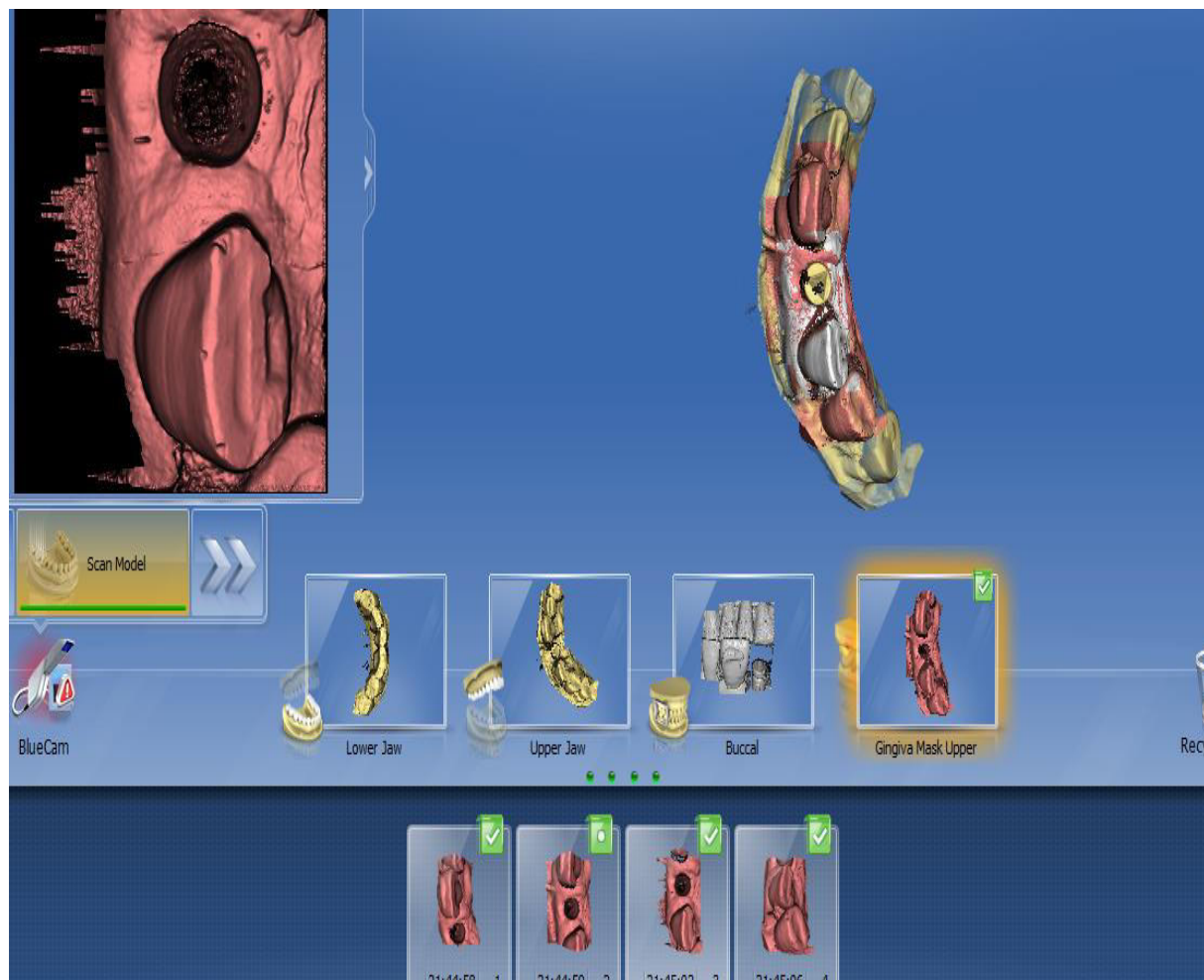
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- 상악이 완전히 촬영이 끝난 상태입니다. 이후 대합치와 교합(Bite)을 순서대로 촬영합니다.

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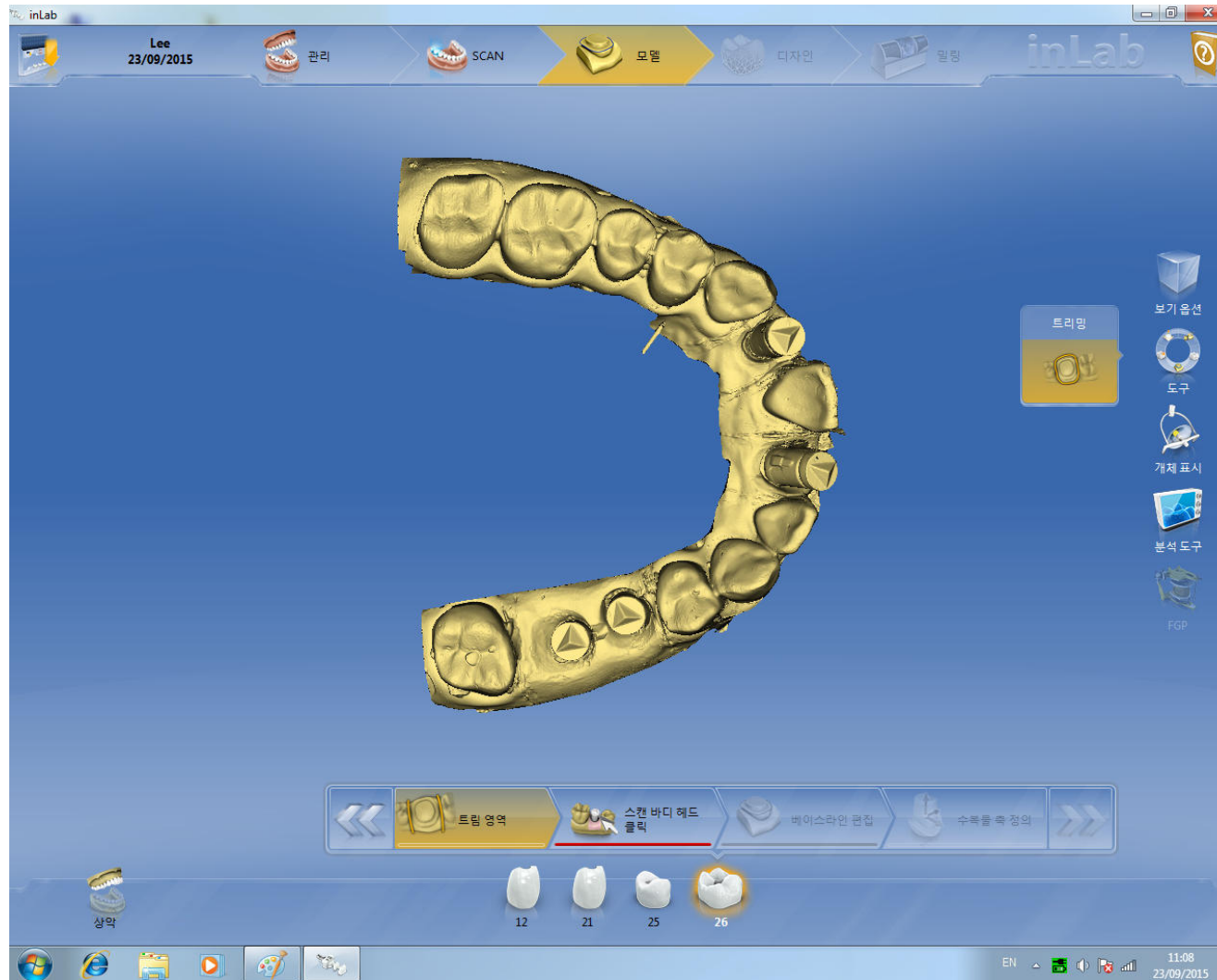
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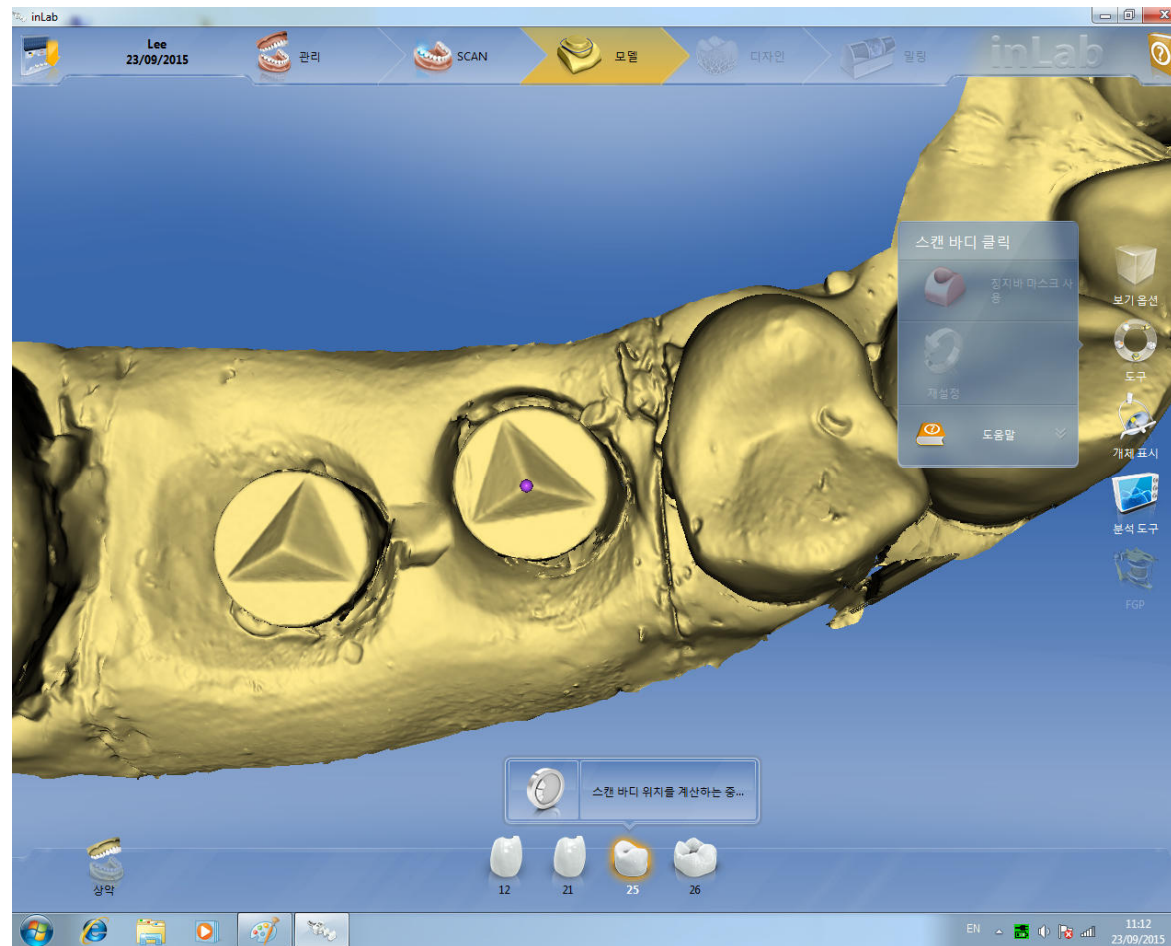


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Cerec용 Link Abutment

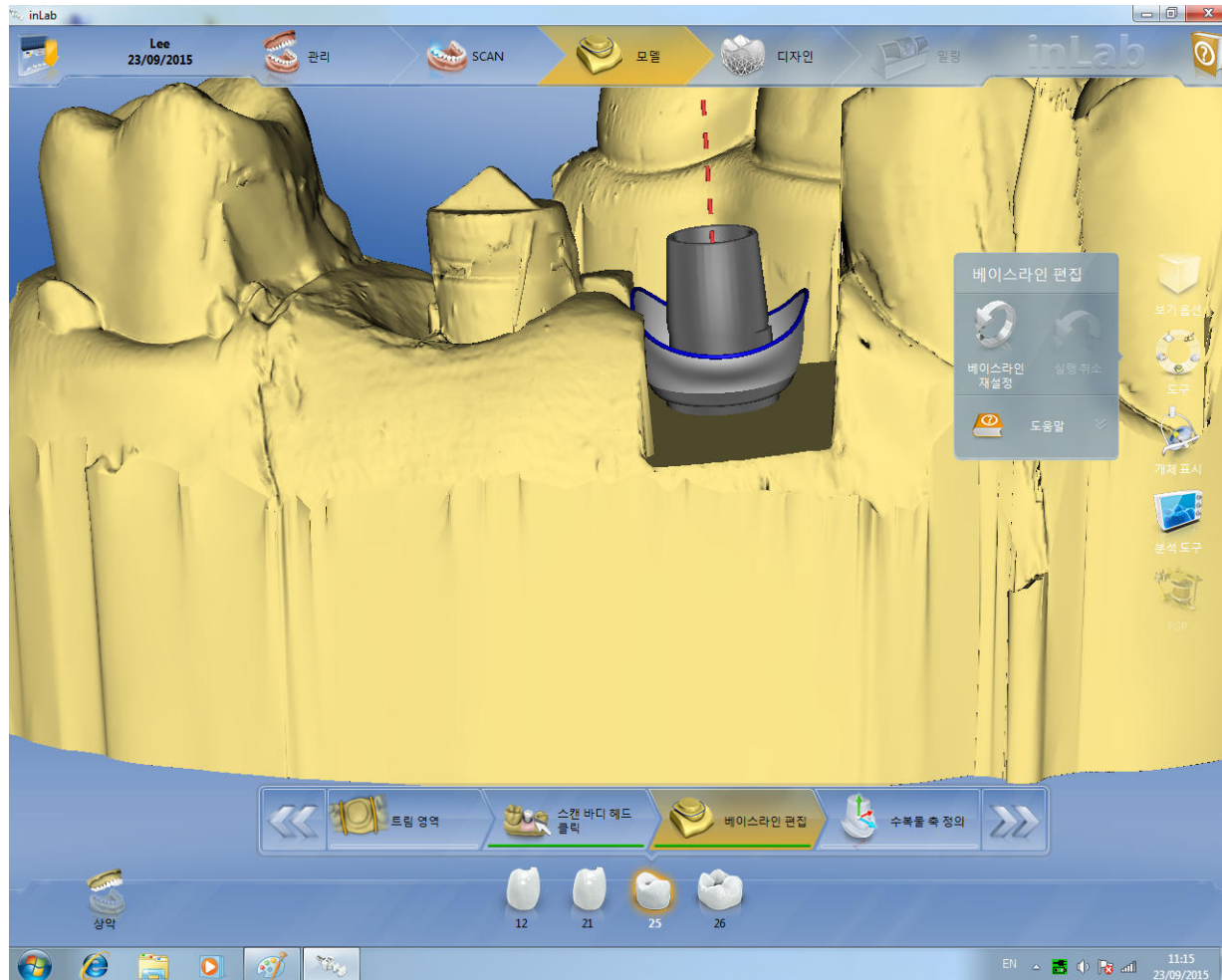


④ 보철물 Design



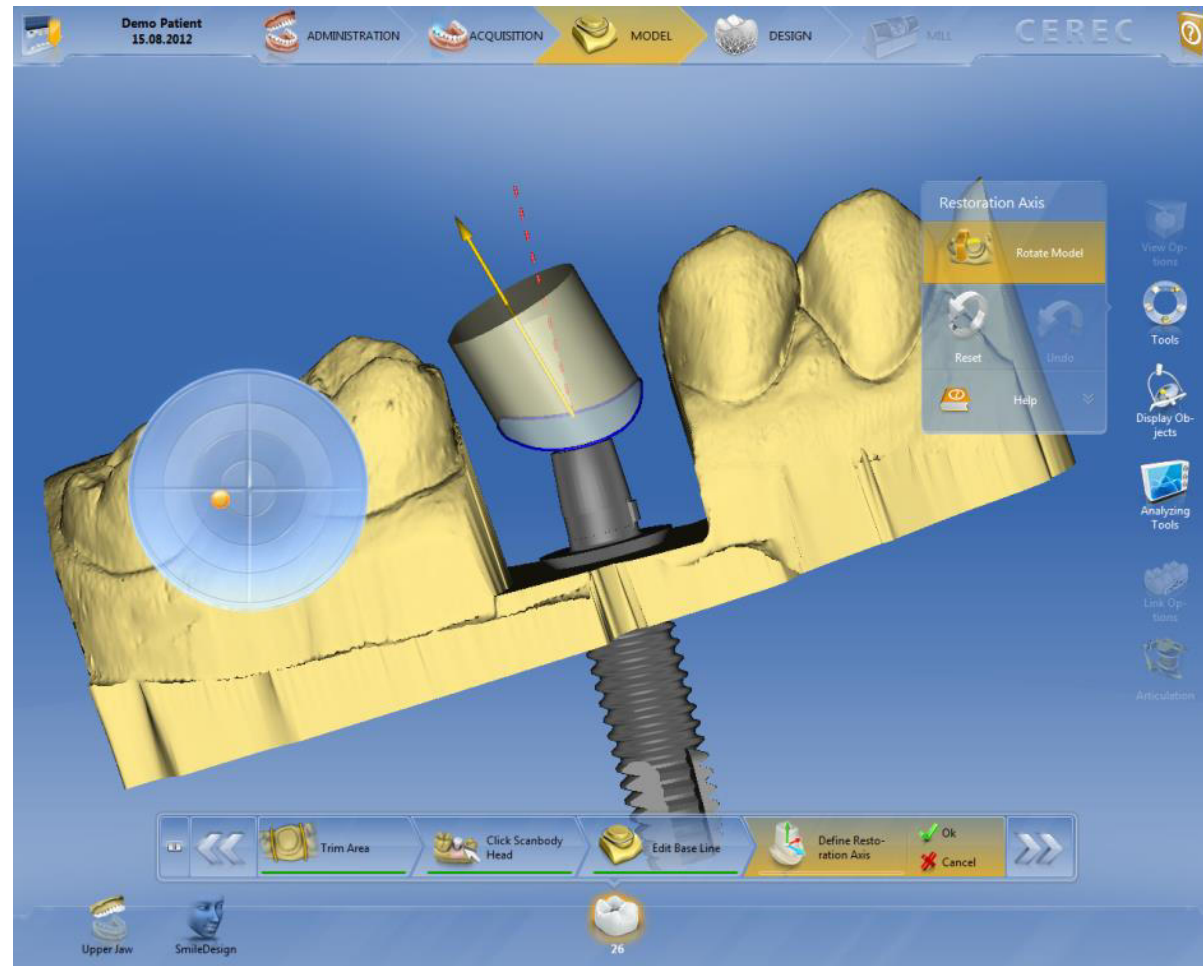
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Link Abutment for CEREC



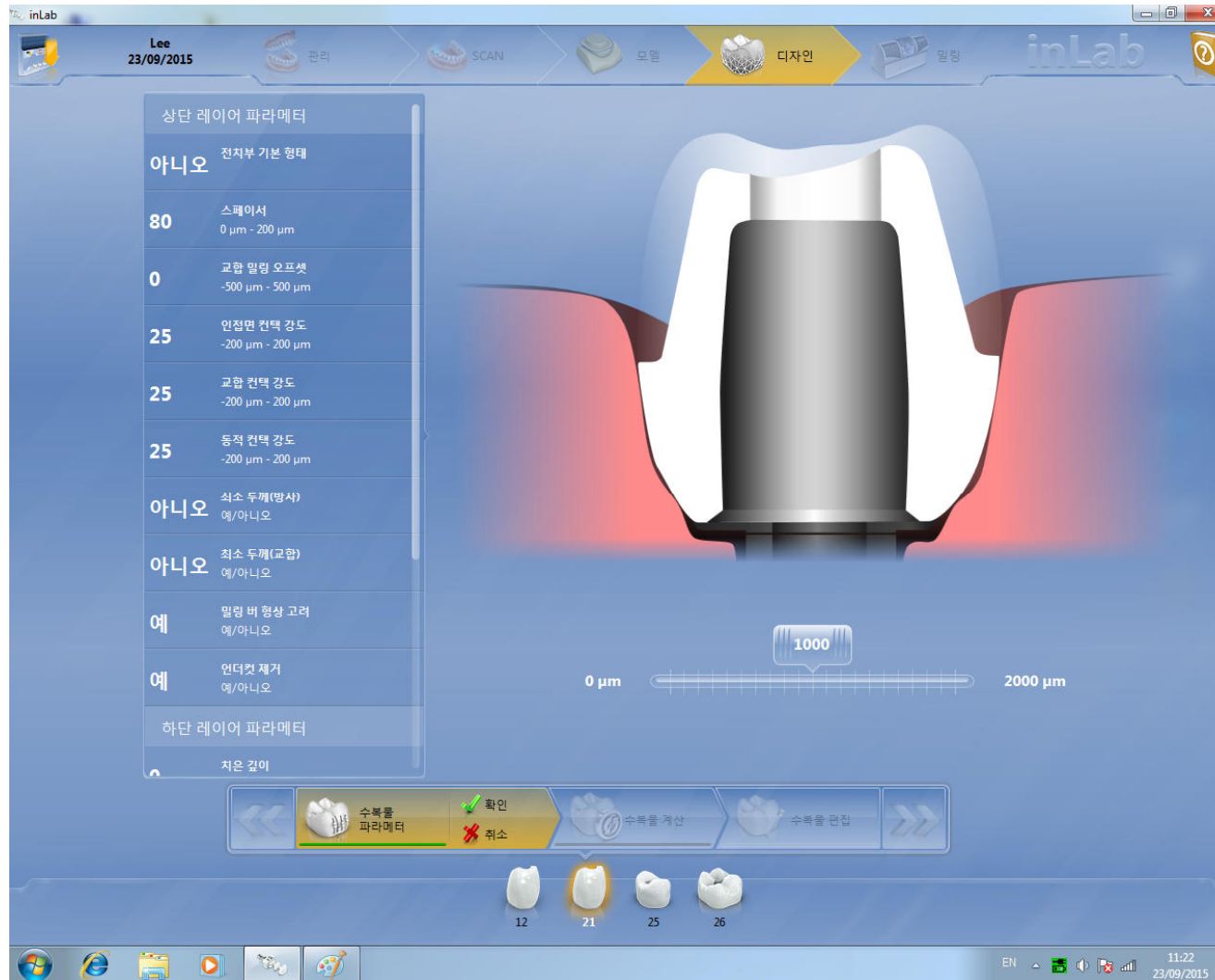
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Top layer parameters	
NO	Anterior Basic Shape
60	Spacer 0 μm - 200 μm
0	Occlusal Milling Offset -500 μm - 500 μm
25	Proximal Contacts Strength -200 μm - 200 μm
25	Occlusal Contacts Strength -200 μm - 200 μm
500	Minimal Thickness (Radial) 0 μm - 2000 μm
700	Minimal Thickness (Occlusal) 0 μm - 2000 μm
YES	Consider Instrument Geometry YES/NO
YES	Remove Undercuts YES/NO

Bottom layer parameters	
500	Minimal Thickness (Radial) 0 μm - 2000 μm
2000	Minimal Thickness (Occlusal) 0 μm - 2000 μm
0	Gingival Depth -2000 μm - 0 μm
0	Gingival Placement Pressure -1000 μm - 1000 μm
1000	Shoulder Width 0 μm - 2000 μm
4	Telescope Angle 0 ° - 15 °